IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: HONGYU YUE, WESLEY NATZLE

Application No.:	Confirmation No:
Filed: March 30, 2004	Group No.:
	Examiner

For: METHOD AND SYSTEM FOR PERFORMING A CHEMICAL OXIDE REMOVAL
PROCESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: HONGYU YUE
Citizenship: USA
Residence: Austin, TX 78479

Second applicant: WESLEY NATZLE
Citizenship: USA
Residence: New Paltz, NY 12561

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: METHOD AND SYSTEM FOR PERFORMING A CHEMICAL OXIDE
REMOVAL PROCESS

Docket number assigned to this application: 071469-0307692
Suggested Classification: Class:
Subclass:
Technology Center to which subject matter is assigned:

Total number of drawing sheets: 20
Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Assignee information

The assignee(s) of this application is/are:

Tokyo Electron Limited
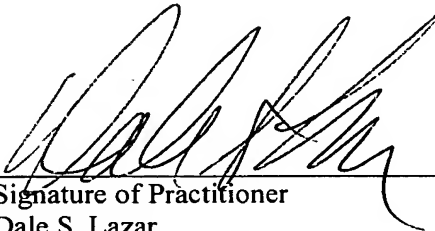3-6, Akasaka 5-chome, Minato-ku
Tokyo, 107
JAPAN
Extent of interest of assignee in application: 50%

International Business Machines Corporation
New Orchard Road
Armonk, NY 10504
Extent of interest of assignee in application: 50%

Date: March 30, 2004

PILLSBURY WINTHROP LLP
P.O. Box 10500
McLean, VA 22102
Customer No. 00909

Signature of Practitioner
Dale S. Lazar
Registration No. 28872
(703) 905-2126